

Docket No.: 071971-0390

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	
Kunimasa TAKAHASHI, et al.	:	
Application No.: Not yet assigned	:	Group Art Unit: Not yet assigned
Filed: October 20, 2005	:	Examiner: Not yet assigned
For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATION THE SAME	:	

**PRELIMINARY AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please amend the application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** begin on page 3 of this paper.

**Remarks / Arguments** begin on page 7 of this paper.